



AF/2800

MS AF
REPLY UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2815

PATENT
3430-0131P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:	HWANG, Kwang-Jo	Conf.:	5562
Appl. No.:	09/648,111	Group:	2815
Filed:	August 25, 2000	Examiner:	Brock II, P.
For:	METHOD OF PATTERNING A METAL LAYER IN A SEMICONDUCTOR DEVICE		

LARGE ENTITY TRANSMITTAL FORM
FOR REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 26, 2003

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Sir:

Transmitted herewith is an amendment in the above-identified application.

- ☐ The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.
- ☐ The enclosed document is being transmitted via facsimile.

The fee has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR		PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	30	-	30	=	0	\$ 18	\$0.00
INDEPENDENT	4	-	4	=	0	\$ 84	\$0.00
<input type="checkbox"/> FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM						\$280	\$0.00
						TOTAL	\$0.00

- ☐ Petition for () month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$0.00 for the extension of time.
- ☒ No fee is required.
- ☐ Check(s) in the amount of \$0.00 is(are) enclosed.
- ☐ Please charge Deposit Account No. 02-2448 in the amount of \$0.00. This form is submitted in triplicate.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By Esther H. Choy #40,953
Joseph A. Kolasch, #22,463

JAK
JAK/PLS/gf
3430-0131P

P.O. Box 747
Falls Church, VA 22040-0747
(703) 205-8000

Attachment(s)



**MS AF
RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2815**

PATENT
3430-0131P

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S): HWANG, Kwang-Jo

CONF.: 5562

SERIAL NO.: 09/648,111

GROUP: 2815

FILED: August 25, 2000

EXAMINER: BROCK II

FOR: METHOD OF PATTERNING A METAL LAYER IN A
SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 C.F.R. 1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 26, 2003

Dear Sir:

In response to the final Office Action dated June 26, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes Amendments to the Claims and Remarks.

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